

**APPLICATION DATA SHEET****Application Information**

Application type:: Regular  
Subject matter:: Utility  
CD-ROM or CD-R?: None  
Title:: PHOTORESIST BASE MATERIAL, METHOD  
FOR PURIFICATION THEREOF, AND  
PHOTORESIST COMPOSITION  
  
Attorney Docket Number:: 28955.1048  
Request for Early Publication:: No  
Request for Non-Publication:: No  
Total Drawing Sheets::  
Small Entity?: No

**Applicant Information**

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Applicant Authority Type:: Inventor  
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**Correspondence Information**

Correspondence Customer Number:: 27890

**Representative Information**

Representative Customer Number:: 27890

**Domestic Priority Information**

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This application	National Stage of	PCT/JP2003/011137	09/01/03

**Foreign Priority Information**

<b>Country::</b>	<b>Application Number::</b>	<b>Filing Date::</b>	<b>Priority Claimed::</b>
Japan	2002-300144	10/15/02	Yes
Japan	2003-112458	04/17/03	Yes